

Contents

List of Contributors VII

- 1 **Introduction: LIGA and Its Applications** 1
Volker Saile
- 2 **X-ray Masks for LIGA Microfabrication** 11
Yohannes Desta and Jost Goettert
- 3 **Innovative Exposure Techniques for 3D Microfabrication** 51
Naoki Matsuzuka and Osamu Tabata
- 4 **Hot Embossing of LIGA Microstructures** 69
Mathias Hecke and Matthias Worgull
- 5 **Exposure and Development Simulation for Deep X-ray LIGA** 103
Jan G. Korvink, Sadik Hafizovic, Yoshikazu Hirai, and Pascal Meyer
- 6 **Design for LIGA and Safe Manufacturing** 143
Ulrich Gengenbach, Ingo Sieber, and Ulrike Wallrabe
- 7 **Commercialization of LIGA** 189
Ron A. Lawes
- 8 **Polymer Optics and Optical MEMS** 205
Jürgen Mohr
- 9 **Refractive X-ray Lenses Produced by X-ray Lithography** 233
Arndt Last
- 10 **RF Applications** 243
Sven Achenbach and David M. Klymyshyn
- 11 **Evolution of the Microspectrometer** 281
Reiner Wechsung, Sven Schönfelder, and Andreas Decker

12	Actuator Manufacture with LIGA Processes	297
	<i>Todd Christenson</i>	
13	Development of Microfluidic Devices Created via the LIGA Process	323
	<i>Masaya Kurokawa</i>	
14	Application of Inspection Devices	337
	<i>Yoshihiro Hirata</i>	
15	The Micro Harmonic Drive Gear	351
	<i>Reinhard Degen and Rolf Slatter</i>	
16	Microinjection Molding Machines	395
	<i>Christian Gornik</i>	
17	Filled Resist Systems	415
	<i>Thomas Hanemann, Claas Müller, and Michael Schulz</i>	
18	Dramatic Downsizing of Soft X-ray Synchrotron Light Source from Compact to Tabletop	443
	<i>Hironari Yamada, Norio Toyosugi, Dorian Minkov, and Yoshiko Okazaki</i>	
19	PTFE Photo-fabrication by Synchrotron Radiation	453
	<i>Takanori Katoh and Yanping Zhang</i>	
Index		469